Docket No.: 055071-0310

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Customer Number: 20277

Armin LIEBCHEN

Confirmation Number: 3610

Application No.: 10/705,234

Patent No.: 7,034,919 B2

Group Art Unit: 2851

Filed: November 12, 2003

Examiner: Peter B. Kim

Issued: April 25, 2006

For: METHOD AND APPARATUS FOR PROVIDING LENS ABERRATION

COMPENSATION BY ILLUMINATION SOURCE OPTIMIZATION

REQUEST FOR CERTIFICATE OF CORRECTION UNDER 37 CFR 1.322

Mail Stop CERTIFICATE OF CORRECTIONS Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In reviewing the above-identified patent, a printing error was discovered therein requiring correction in order to conform the Official Record in the application.

The error noted is set forth on the attached copy of form PTO-1050 Rev. 2-93 in the manner required by the Commissioner's Notice.

Specifically, on the title page, page 2, under OTHER PUBLICATIONS, in column 2, in the article by Nishrin Kachwala et al., the following phrase in the title should be corrected: ""160 run line" to -- 160 nm line --. A copy of considered 1449, originally filed with the Information Disclosure Statement on August 8, 2005, showing the correct version of the title is attached for your information and convenience.

10/705,234 7,034,919

The change requested herein occurred as a result of printing the Letters Patent and the Certificate should be issued without expense under Rule 322 of the Rules of Practice. Accordingly, Applicants request issuance of the Certificate of Correction.

Please charge any shortage in fees due in connection with the filing of this paper to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

Please recognize our Customer No. 20277

as our correspondence address.

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Date: August 11, 2006

WDC99 1269315-1.055071.0310

UNITED STATES PATENT AND TRADEMARK OFFICE

CERTIFICATE OF CORRECTION

PATENT NO.

: 7,034,919 B2

APPLICATION NO. : 10/705,234

DATED

: April 25, 2006

INVENTOR(S)

: Armin Liebchen

It is certified that an error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Title page, page 2, column 2, under "OTHER PUBLICATIONS", In the article by "Nishrin Kachwala et al.", line 2, change "160 run line" to - - 160 nm line --.



SHEET 2 OF 2

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INFORMATION DISCLOSURE						ATTY. DOCKET NO. SERIAL NO.					-	
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U.S. PATENT DOCUMENTS												
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.